## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L7	126542	(sem "scanning electron microscope" stm "scanning tunnelling microscope" "optical microscope")	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:22
L8	6591	L7 and ((fet "field effect transistor") (cmos "complementary metal oxide semiconductor") (mosfet "metal oxide semiconductor field effect transistor"))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:24
L9	506	L8 and ("registration marker" marker)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:24
L12	49	L9 and ("registration marker" "trademark" "brand name")	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:27
L13	8	L12 and @ad< "20030820"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:28

1/12/2009 2:46:54 PM

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